

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/783,247
Filing Date February 19, 2004
Inventor Jianxing Li et al.
Assignee Honeywell International Inc.
Group Art Unit 2822
Examiner Novacek, Christy L.
Attorney's Docket No. 30-5082-DIV2
Title: Sputtering Target Compositions, and Methods of Inhibiting Copper
Diffusion into a Substrate

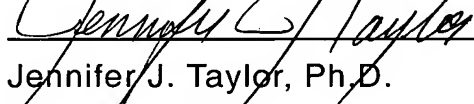
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References –See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached with the exception of U.S. patents and published U.S. applications (1276 Off. Gaz. Pat. Off. 55, 05 Aug 2003). No admission is made regarding whether all the submitted references are prior art. Citation of the referenced art is respectfully requested.

Respectfully submitted,

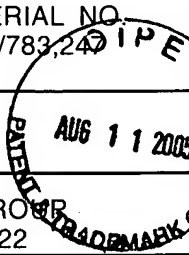
Dated: August 11, 2005

By: 
Jennifer J. Taylor, Ph.D.
Reg. No. 48,711

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 30-5082-DIV2		SERIAL NO. 10/783,247	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Jianxing Li et al.			
				FILING DATE February 19, 2004			
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Sub- class	Filing Date If Appropriate
	AA	3,592,639	07-1971	Schussler et al.			
	AB	6,323,055	11-2001	Rosenberg et al.			
	AC	6,312,779	11-2001	Hirotsune et al.			
	AD	5,781,256	07-1998	Inoue et al.			
	AE	5,170,244	12-1992	Dohjo et al.			
	AF	4,938,798	07-1990	Chiba et al.			
	AG	4,731,116	03-1988	Kny			
	AH	6,827,828	12-2004	Wang			
	AI	2004/0168932	09-2004	Wang			
	AJ	2002/0139667	10-2002	Wang			
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Clas s	Subc lass	Translation Yes No
	AK	JP01230767A	09-1989	Japan			
	AM	JP05171417A	07-1993	Japan			
	AN	JP2003055761A	02-2003	Japan			
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR	ASM Handbook, Vol. 3, Alloy Phase Diagrams, 1992, pg. 375					
	AS	Hansen, Constitution of Binary Alloys, 1958, pg. 1226					
EXAMINER				DATE CONSIDERED			
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							

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U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Sub- class	Filing Date If Appropriate	
	AA	5,896,553	04-1999	Lo				
	AB	5,992,980	11-1999	Hasegawa et al.				
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Clas s	Subc lass	Translation	
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	AM							
	AN							
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	AS							
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